

10/550897

1 / 8

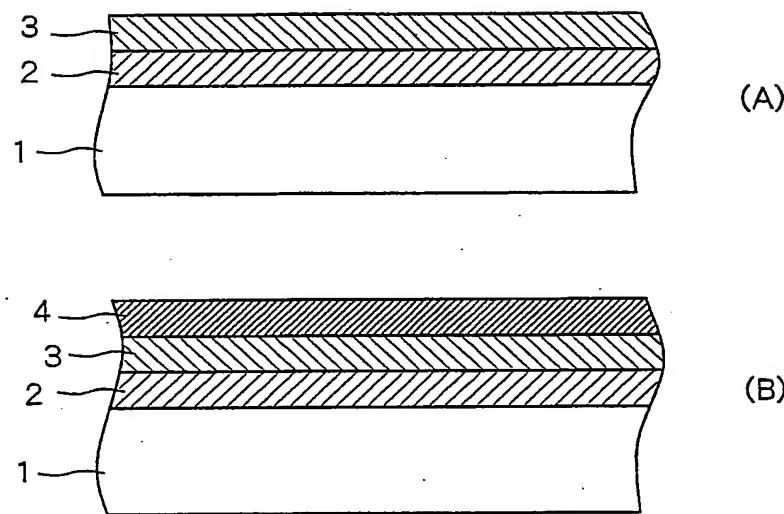


Fig. 1

10/550897

2 / 8

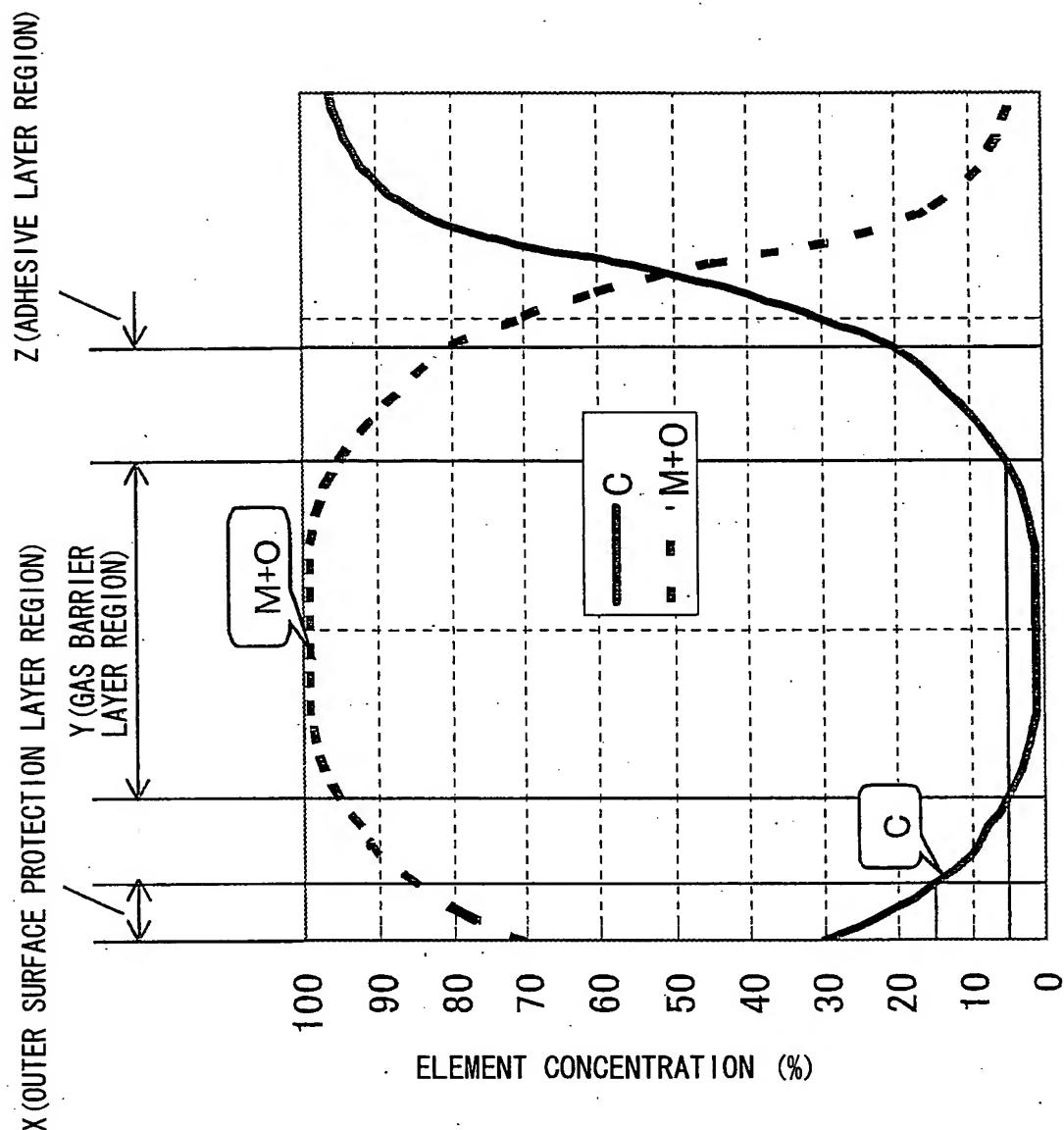


Fig. 2

10/550897

Akira KOBAYASHI, et al. Q90606  
CHEMICAL VAPOR DEPOSITED FILM BASED...  
Filing Date: September 27, 2005  
Abraham J. Rosner 202-293-7060  
3 of 8

3 / 8

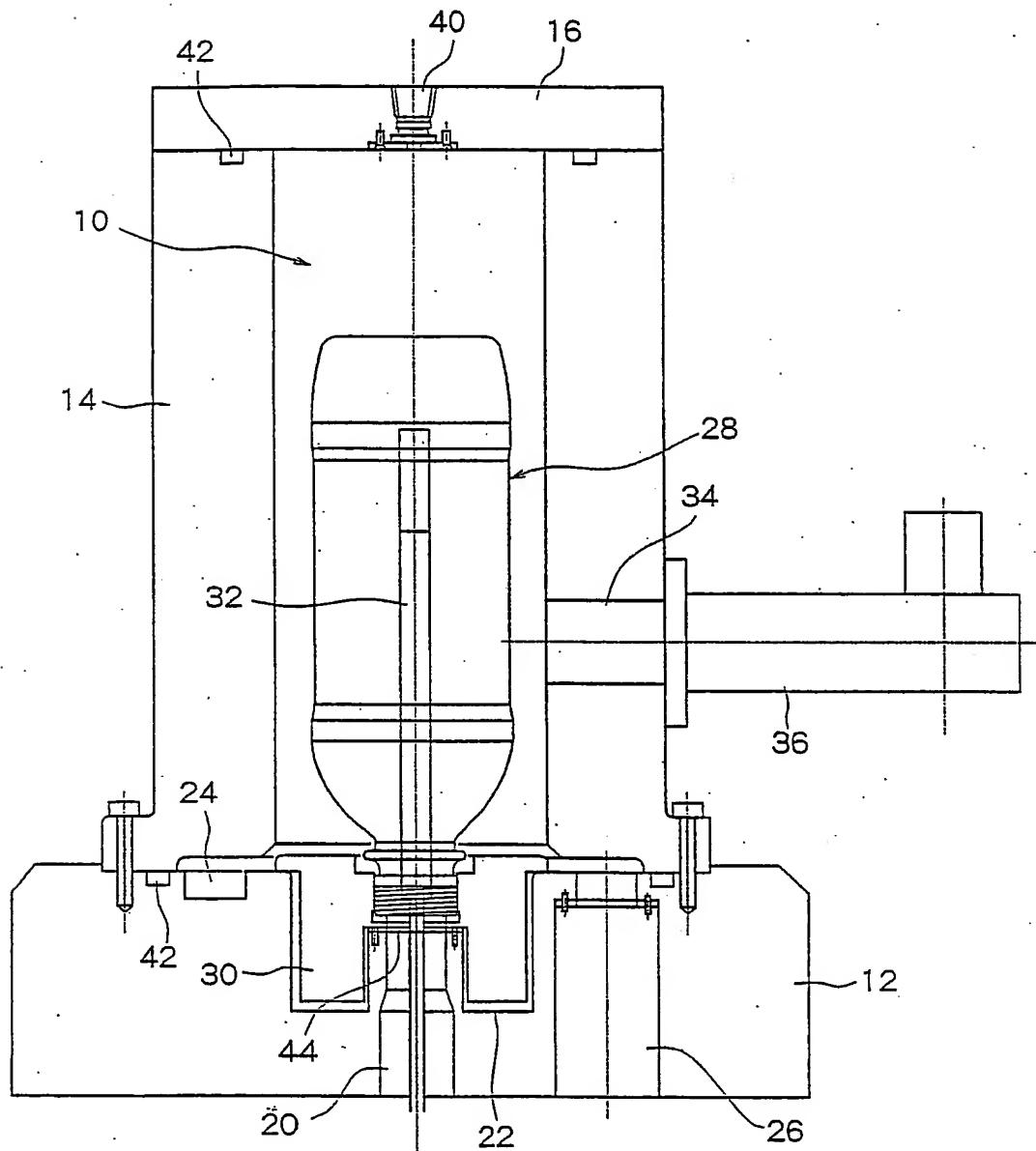


Fig. 3

10/550897

4 / 8

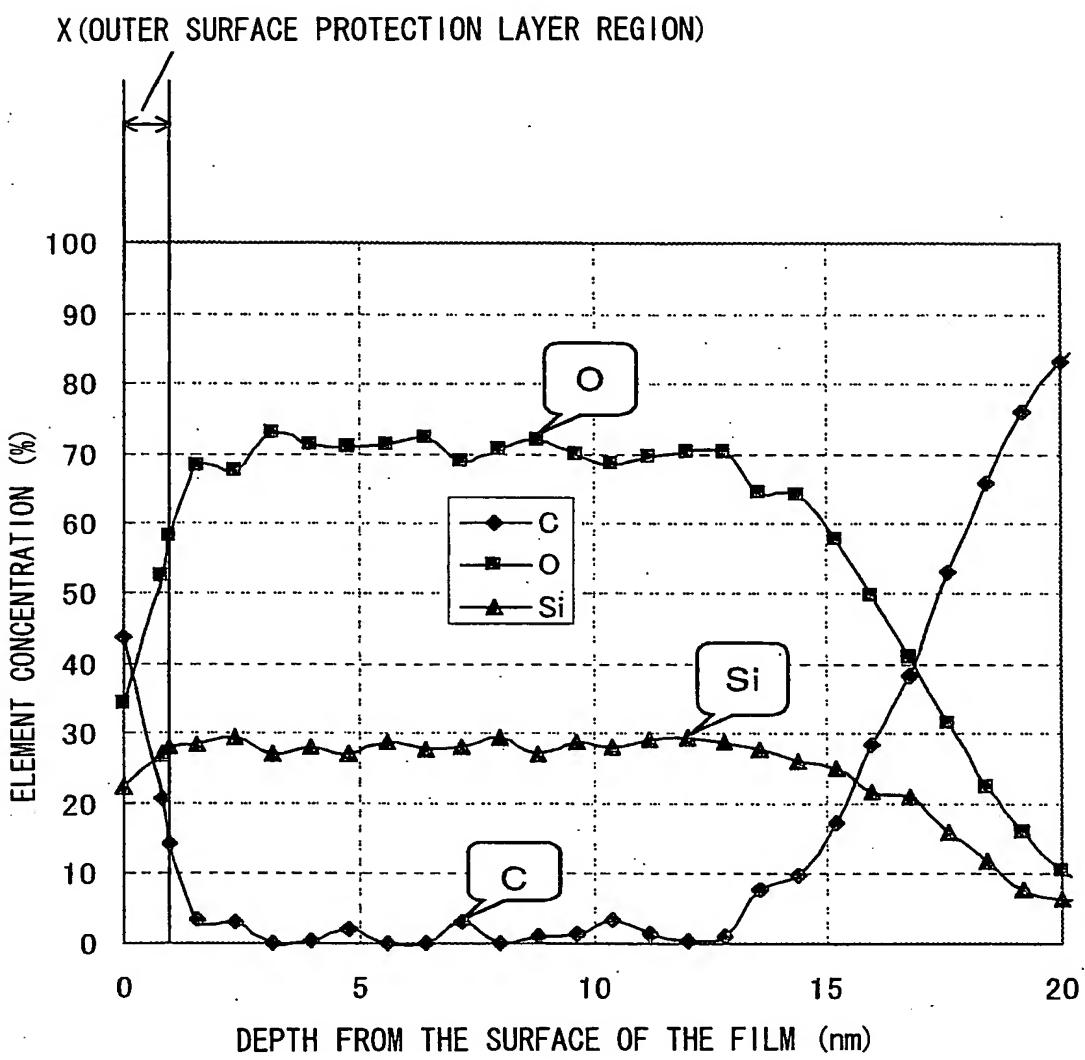


Fig. 4

5 / 8

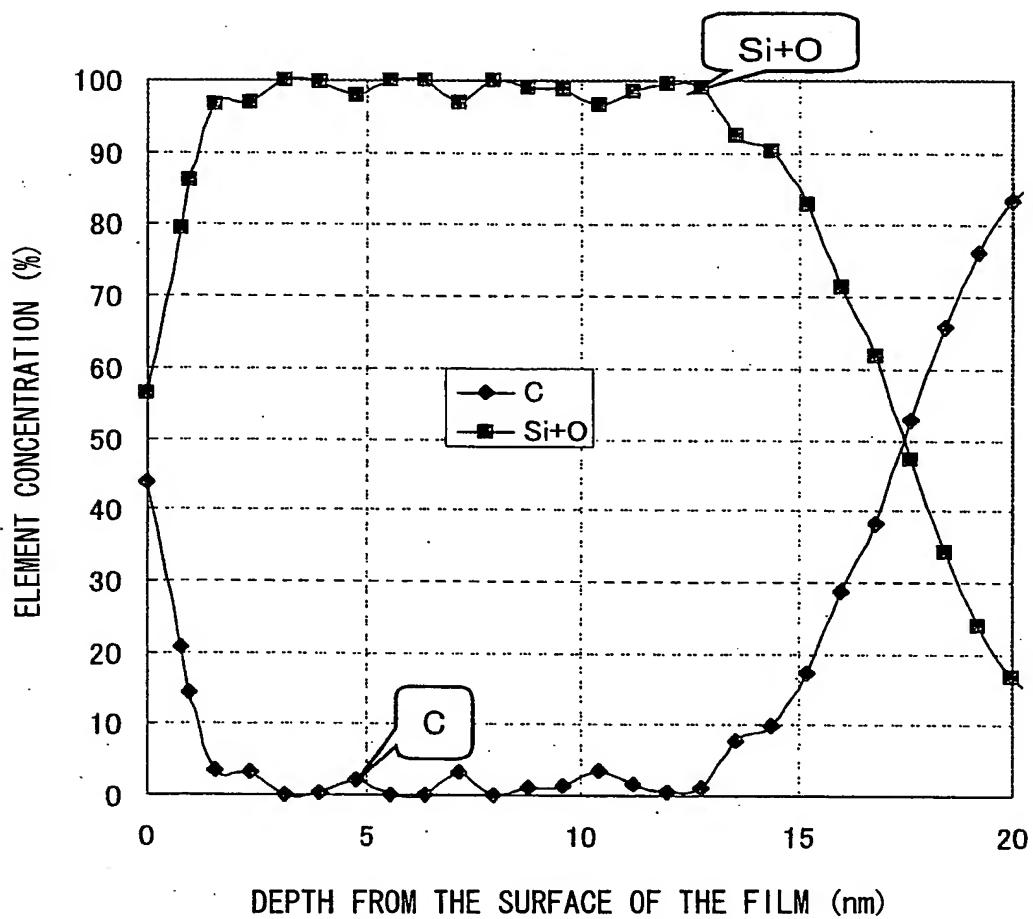


Fig. 5

10/550897

Akira KOBAYASHI, et al. Q90606  
CHEMICAL VAPOR DEPOSITED FILM BASED...  
Filing Date: September 27, 2005  
Abraham J. Rosner 202-293-7060  
6 of 8

6 / 8

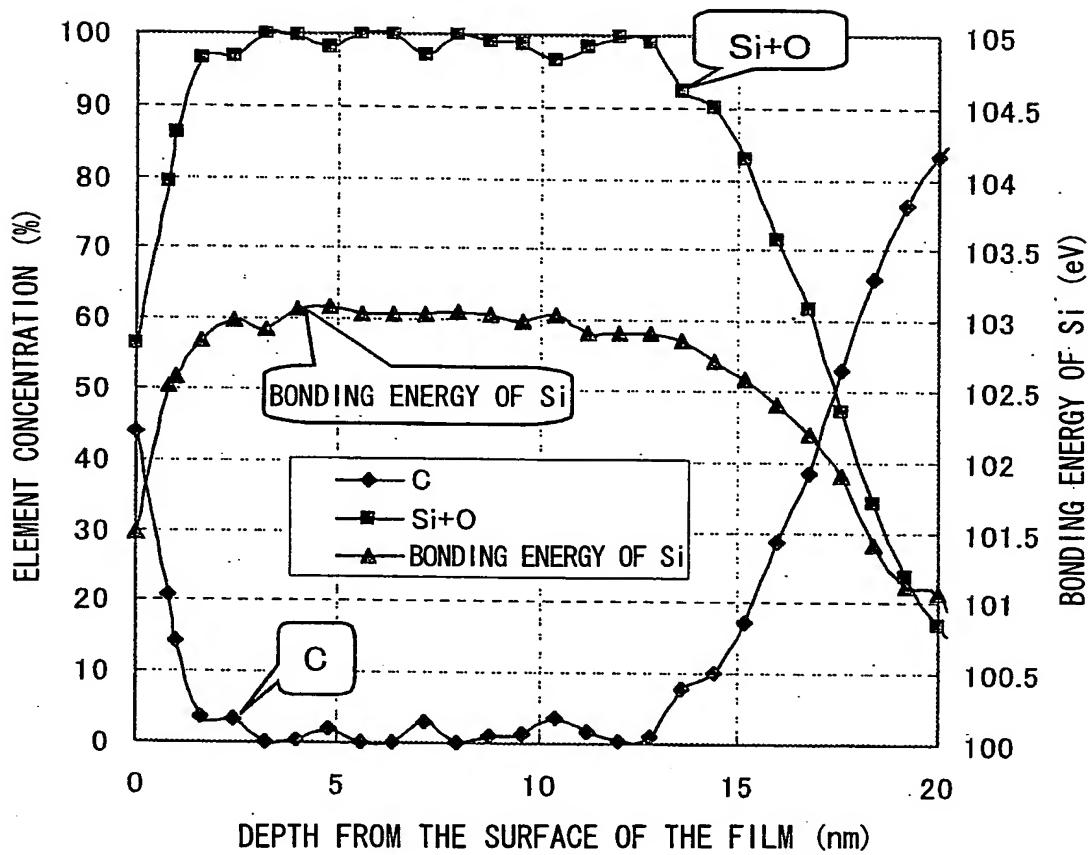


Fig. 6

10/550897

Akira KOBAYASHI, et al. Q90606  
CHEMICAL VAPOR DEPOSITED FILM BASED...  
Filing Date: September 27, 2005  
Abraham J. Rosner 202-293-7060  
7 of 8

7 / 8

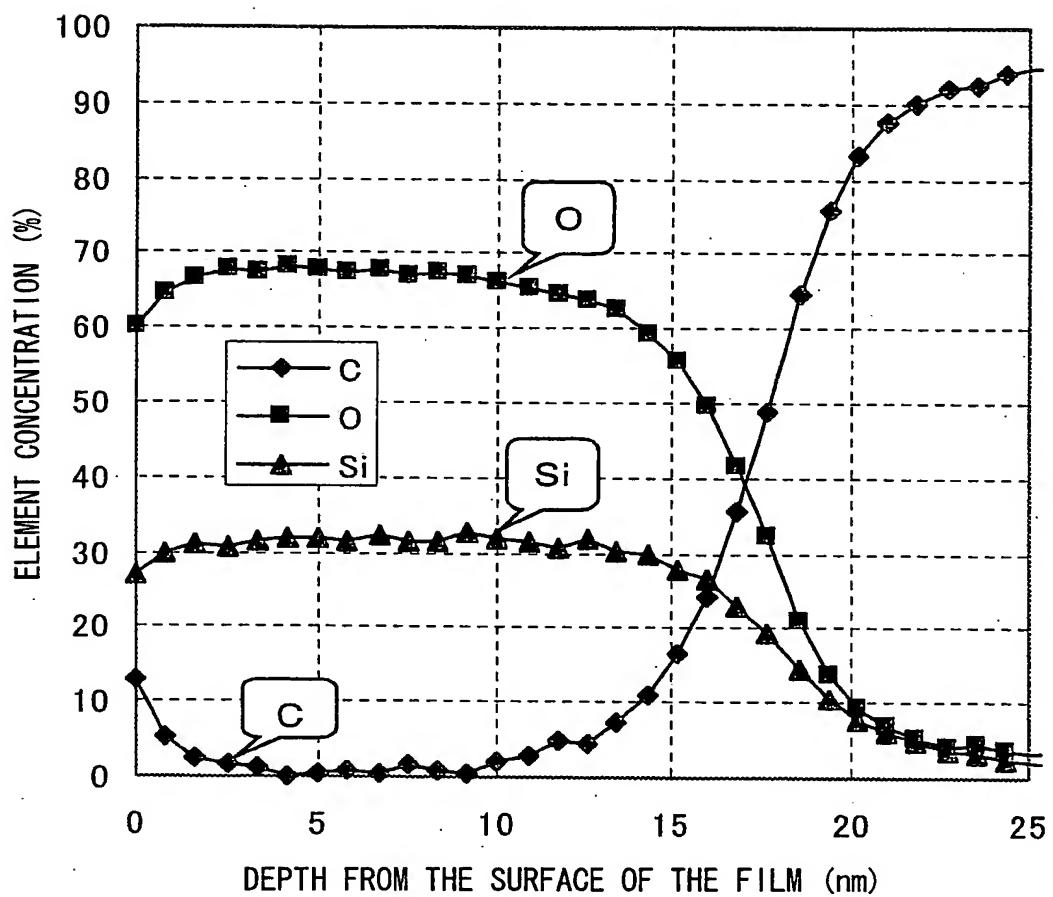


Fig. 7

8 / 8

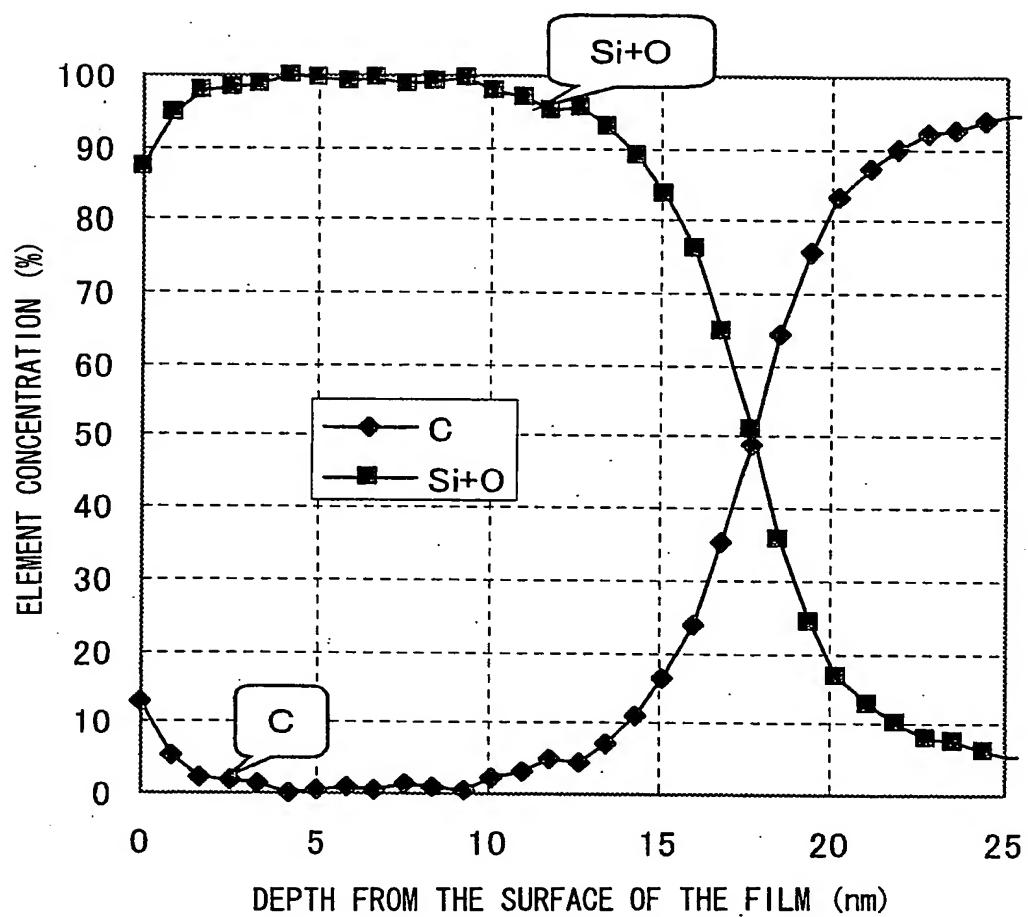


Fig. 8